

Form 1449 (Modified) Information Disclosure Statement By Applicant <small>(Use Several Sheets if Necessary)</small>	Atty Docket No. SUN1P833 Applicant: SOKOLOV et al. Filing Date 05/08/01	Application No.: 09/851,554 Group 2176-2122
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U.S. Patent Documents

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Foreign Patent or Published Foreign Patent Application

Other Documents

Other Documents		
Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
MY	1	Lindholm et al, "The Java™ Virtual Machine Specification", (Sept, 1996), Sun Microsystems, Inc., Chapters 1-10 (173 pp.)
Examiner	<i>Michael Yigdall</i>	Date Considered 6/2/04

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Form 1449 (Modified)

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Atty Docket No.
SUN1P833/P6212

Application No.:
09/851,554

Applicant:
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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-Class	Filing Date
	A1						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
MY	B1	WO 9848354A	10/29/98	WIPO	—	—	X	
MY	B2	WO 9910811	03/04/99	WIPO	—	—	X	

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication						
MY	C1	Agesen et al., "Garbage Collection and Local Variable Type-Precision Liveness in Java™ Virtual Machines, Association for Computing Machinery, New York, Vol. 33, No. 5, May 19, 1998, pp. 269-279						
MY	C2	Barabash et al., "Mostly Accurate Stack Scanning", Proceedings of the Java/Sup Tm/ Virtual Machine Research and Technology Symposium, Monterey, California, April 23 and 24, 2001, pp. 153-170						
Examiner	<i>Michael Yagdell</i>		Date Considered 6/2/04					

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